Docket No: 740756-002683

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of)
Setsuo NAKAJIMA)
Application No. 10/752,993) Art Unit: 2814
Filed: January 8, 2004) Confirmation No. 6484
For: METHOD FOR MANUFACTURING A SEMICONDUCTOR DEVICE)

INFORMATION DISCLOSURE STATEMENT

United States Patent and Trademark Office Customer Window, Mail Stop RCE Randolph Building 401 Dulany Street Alexandria, VA 22314

Sir:

In accordance with the duty of disclosure as set forth in 37 C.F.R. §1.56, Applicants hereby submit the following information in conformance with 37 C.F.R. §§ 1.97 and 1.98. In accordance with the policies of the U.S. Patent and Trademark Office, only copies of newly cited foreign patents and non-patent literature are being submitted.

It is requested that the accompanying PTO-1449 be considered and made of record in the above-identified application. It is respectfully requested that an Examiner initialed copy of this form be returned to the undersigned.

The Commissioner is hereby authorized to charge any fee required in connection with this filing, and any additional fees which may be required, or credit any overpayment to Deposit Account No. 19-2380.

Respectfully submitted,

By: /Jeffrey L. Costellia, Reg.#35483/ Jeffrey L. Costellia Registration No. 35,483

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